

PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10080848	FILING DATE 02/22/2002	CLASS 257.128	SUBCLASS 706	GAU 1765	EXAMINER Deo
----------------------	---------------------------	------------------	-----------------	-------------	-----------------

**APPLICANTS: Ohtake Hiroto; Saitoh Shinobu; Tada Munehiro; Hayashi Yoshihiro;

**CONTINUING DATA VERIFIED:

jd

** FOREIGN APPLICATIONS VERIFIED:

JAPAN 047358/2001 02/22/2001

2002/0155639

PG-PUB ☒ DO NOT PUBLISH ☐

RESCIND ☐

Foreign priority claimed ☐ yes ☐ no
35 USC 119 conditions met ☐ yes ☐ no
Verified and Acknowledged Examiners's initials

ATTORNEY DOCKET NO

KRM-00101

TITLE : Method of manufacturing a semiconductor device capable of etching a multi-layer of organic films at a high selectivity

U.S. DEPT. OF COMM. PAT. & TRADEMARK OFFICE, FORM 12-54 94

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G.
Assistant Examiner		DRAWING	
ISSUE FEE		Sheets Drwg.	Figs. Drwg.
Amount Due	Date Paid	Print Fig.	
Primary Examiner		Applicant Examiner	
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	
WARNING: The information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368, Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only.			

FILED WITH:

☐ DISK (CRF)

☐ CD-ROM

(Attached in pocket on right inside flap)

BEST AVAILABLE COPY